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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Application Number : 10/724,133 Confirmation No. 1214  
Applicant : Joon Hyeon LEE  
Filed : December 1, 2003  
Tech Cntr/AU : 1765  
Examiner : Duy Vu Nguyen Deo  
Entitled : METHOD OF FORMING METAL LINE LAYER IN SEMICONDUCTOR DEVICE  
Attorney Reference : 123034-05004921  
Customer Number : 43569

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT/RESPONSE TRANSMITTAL**

Transmitted herewith is an amendment/response for this application.

**EXTENSION OF TIME**

A petition for extension of time under 37 C.F.R. 1.136 is not believed necessary.

**CLAIM FEES**

The claim fees have been calculated as follows:

|  | CLAIMS<br>REMAINING<br>AFTER<br>AMENDMENT | HIGHEST NO.<br>PREVIOUSLY<br>PAID FOR | PRESENT<br>EXTRA | RATE            | ADDITIONAL<br>FEE |
|--|---|---------------------------------------|------------------|-----------------|-------------------|
| Total  | 11  | -                                     | 20               | = 0 x \$ 50.00  | = \$ 0.00         |
| Independent  | 1   | -                                     | 3                | = 0 x \$ 200.00 | = \$ 0.00         |
| FIRST PRESENTATION OF MULTIPLE DEP. CLAIM+ \$ 360.00 |   |                                       |                  |                 | = \$ 0.00         |
| TOTAL ADDITIONAL CLAIM FEE DUE                       |   |                                       |                  |                 | \$ 0.00           |

**FEE PAYMENT**

Authorization is given herein to charge the any deficiencies in the fees not specifically authorized herein, or to further credit any overpayments, to Deposit Account No. 503-121 in order to maintain the pendency of this application.

Intellectual Property Department  
Mayer Brown Rowe & Maw LLP  
1909 K Street, N.W.  
Washington, D.C. 20006-1101

  
Yoon S. Ham  
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(202) 263-3280

Date: February 22, 2006



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**RESPONSE AFTER FINAL REJECTION**

Sir:

Responsive to the Office Action mailed December 27, 2005, kindly enter the following amendments and remarks.